



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

February 12, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

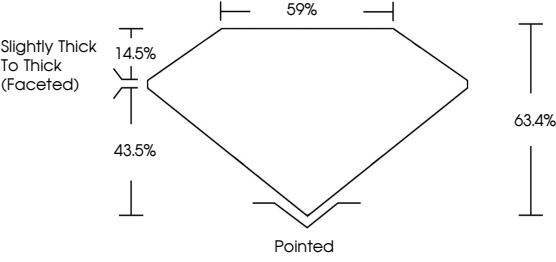
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG774637996

Report verification at [igi.org](#)

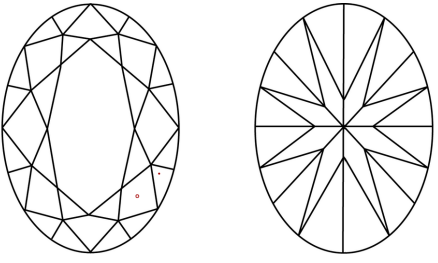
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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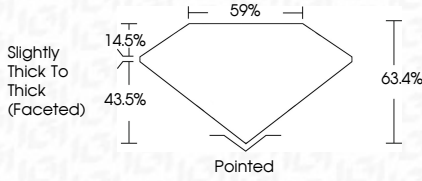
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IGI



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February 12, 2026

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OVAL BRILLIANT

9.04 X 6.58 X 4.17 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Slightly Thick To Thick (Faceted)

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.58 CARAT

F

VS 1

63.4%

59%

Pointed

EXCELLENT

EXCELLENT

NONE

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